

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination ZHENG ET AL.	
		Examiner JUN LI	Art Unit 1793	Page 1 of 1

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NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
U	Abstract of Shen et al (CN85100996)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))
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